The American Vacuum Society AVS

An interdisciplinary, professional Society involved in a variety of disciplines - chemistry, physics, biology, mathematics, and all engineering disciplines - through common interests related to the basic science, technology development, and commercialization of materials, interfaces, and processing.



Special Anniversary Membership Rates & Benefits



In honor of the AVS 60th Anniversary, 2013 dues for new & renewing full members will be \$60

AVS Community–

Advances the Science & Technology of Materials, Processing, & Interfaces



- Networking
- Career Services



 Training & Professional Development



 Technical Conferences, Meetings, & Exhibits



- Professional & Student Awards
- Leadership Opportunities



 Technical Resources & Online Forums



JVST A:

- Surfaces
- Films
- Vacuum



JVST B:

- Nanometer Structures
- Microelectronics
- · Processing, Measurement, & Phenomena



Biointerphases:

- Open Access
- Quantitative Data on Biological & Soft Matter Interfaces
- Experiments, Modeling, Theory, & Applications



Surface Science Spectra (SSS):

- Reference Spectra & Database for Individuals or Analytical Laboratories
- Technological Materials

Governance

- President
 - Elected for one year
- President-Elect, Past-President
- Board of Directors
 - Govern the society, serve two-year terms
- Trustees
 - Evaluate award packages, serve three-year terms
- Committees
- Symposium Program Chair
- Divisions
 - Have their own awards, primarily for students
- Regional, International, and Student Chapters

AVS Divisions and Groups

- Advanced Surface Engineering
- Applied Surface Science
- Biomaterial Interfaces
- Electronic Materials and Processing
- Magnetic Interfaces and Nanostructures
- Nanometer-Scale Science and Technology
- Plasma Science and Technology
- Surface Science
- Thin Film
- Vacuum Technology
- Manufacturing Science and Technology Group
- MEMS/NEMS Group

2014 Awards Nominations

Major Awards Nominations Deadline: March 31, 2014

- Outstanding Research: Medard W. Welch Award
- Outstanding Contributions to the Solution of Technological Problems: Albert Nerken Award
- Outstanding discoveries and inventions: Gaede-Langmuir Award
- •Outstanding Theoretical or Experimental Work by a Young Scientist or Engineer: Peter Mark Memorial Award
- •Outstanding Performance in Technical Support of Research and Development: George T. Hanyo Award
- Sustained and Outstanding Technical Contributions: Fellow of the Society
- Eminent Service to AVS: Honorary Membership

Graduate Student & Divisional Awards Nominations Deadline: May 2014

Outstanding research by a graduate student: Society Student Awards including the Dorothy M. and Earl S. Hoffman Award, Nellie Yeoh Whetten Award, Russell and Sigurd Varian Award, Dorothy M. and Earl S. Hoffman Scholarships. Graduate Research Award as well as numerous Divisional Awards in technical areas of interest to AVS.

Students may apply for a National Student Awards (Graduate Research Award/Top Level Award) and one Division Group Award in a given year.

AVS Membership

Be Part of the AVS Community—

Join Us in Advancing the Science & Technology of Materials, Processing, & Interfaces

Expands Your Network

- Form valuable contacts in academia, industry, and government
- Collaborate with engineers, physicists, chemists, mathematicians, and biologists all working in materials, interfaces, and processing

Enhances Your Scientific & Professional Knowledge

- JVST A, B, and a FREE subscription to SSS online
- International Symposia & Exhibitions and Topical Conferences
- Local Chapter Activities and Meetings
- Professional Development Training and Workshops

Provides Opportunities to Develop & Practice Your Leadership Skills

- · Lead or volunteer on a local, national, or international committee or division
- Develop symposia programming
- Participate in advocacy programs

Offers Discounts on Subscriptions, Meeting Attendance, Hotels, Insurance, & Much More





